

RECEIVED  
CENTRAL FAX CENTER

APR 25 2007

U.S.S.N. 10,656,986

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lu et al.

Group Art Unit: 2813

Serial No.: 10,656,986

Examiner: Doty, H.A.

Filed: 09/04/2003

In Response to Office Action

Dated: 02/07/2007

For: MULTIPLE EXPOSURE METHOD FOR FORMING  
PATTERNED PHOTORESIST LAYER

Attorney Docket No.: 67,200-1145(2002-1332)

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION**

I hereby certified that this correspondence is (1) ☐ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on May\_\_\_\_, 2007; or (2) ☒ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571)-273-8300 on ~~May~~ <sup>Apr</sup> 25, 2007.

Randy W. Tung

Printed Name

  
Signature4/25/07  
Date

Please forward all correspondence to  
TUNG & ASSOCIATES  
838 W. Long Lake Road, Suite 120  
Bloomfield Hills, MI 48302

U.S.S.N. 10,656,986

RECEIVED  
CENTRAL FAX CENTER  
APR 25 2007

RESPONSE TO OFFICE ACTION

Assistant Commissioner  
for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 02/07/2007,  
please enter the following amendments and consider the following  
remarks.